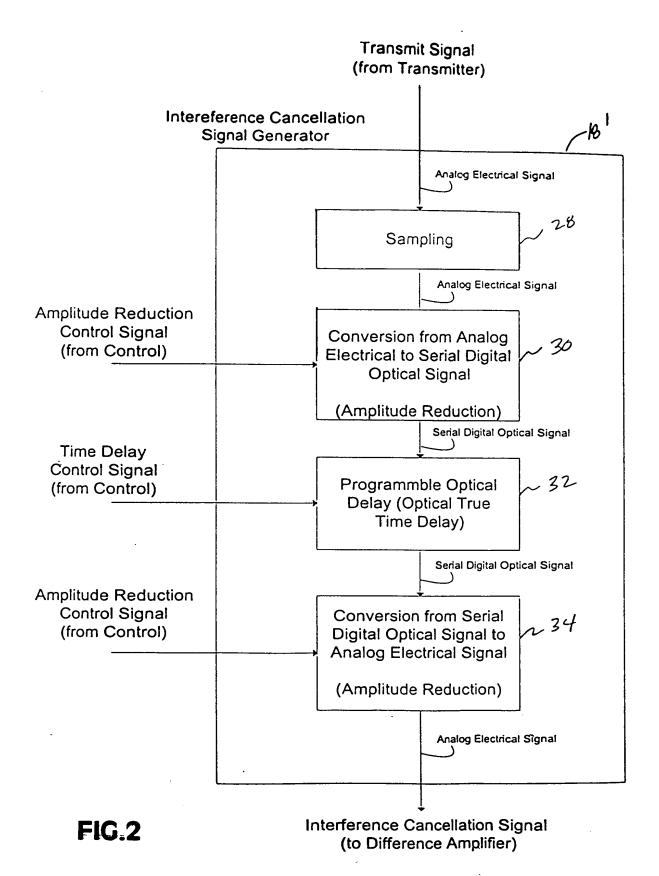


FIG. 1



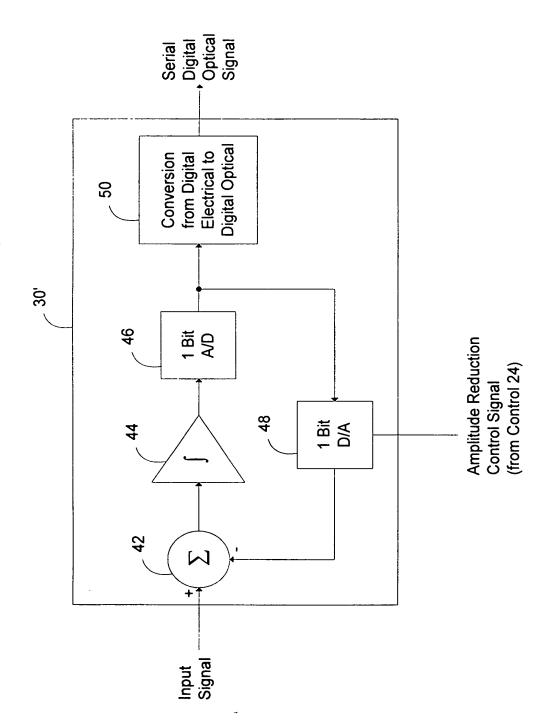
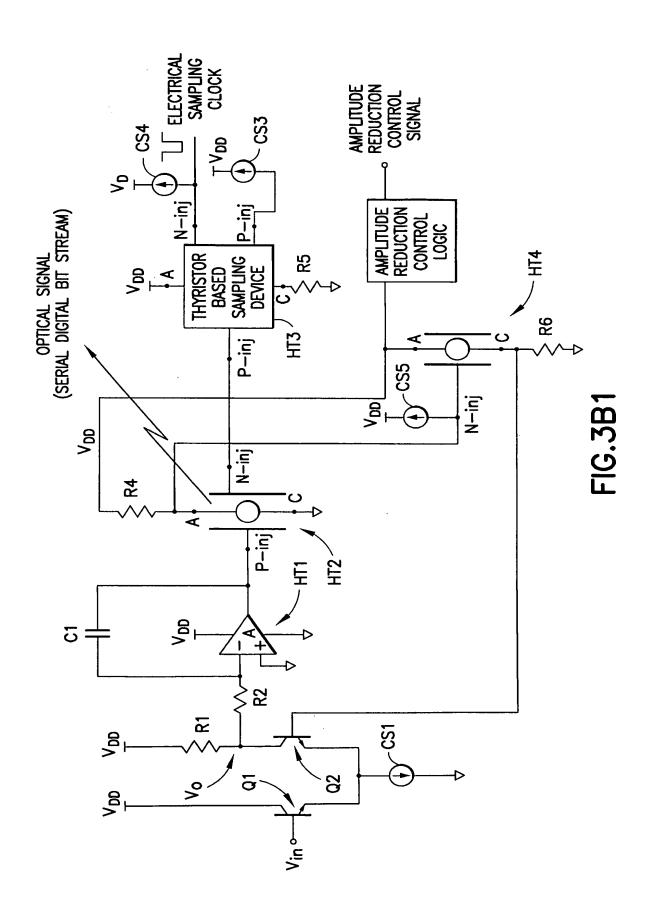
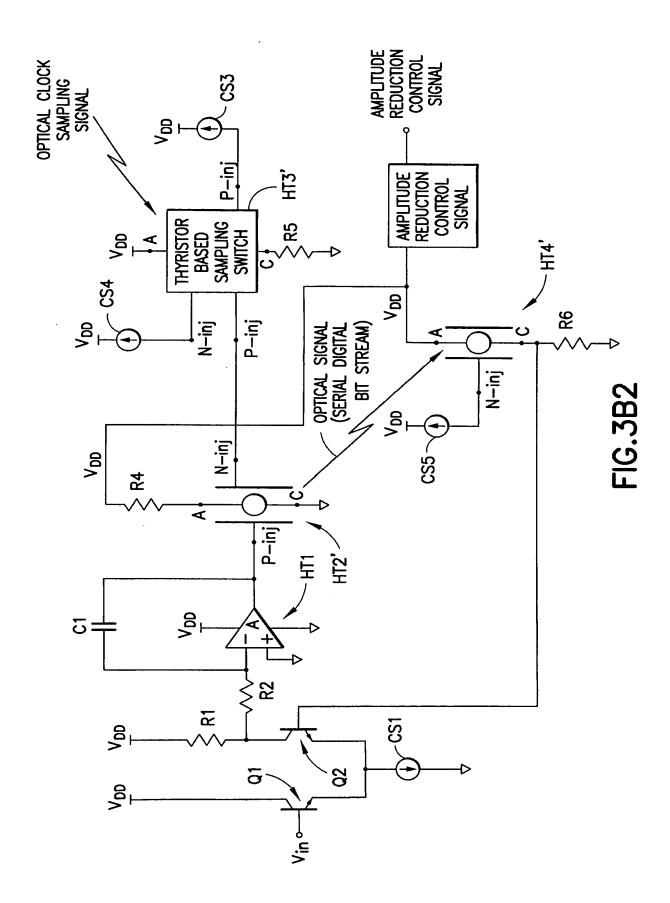


FIG. 3A





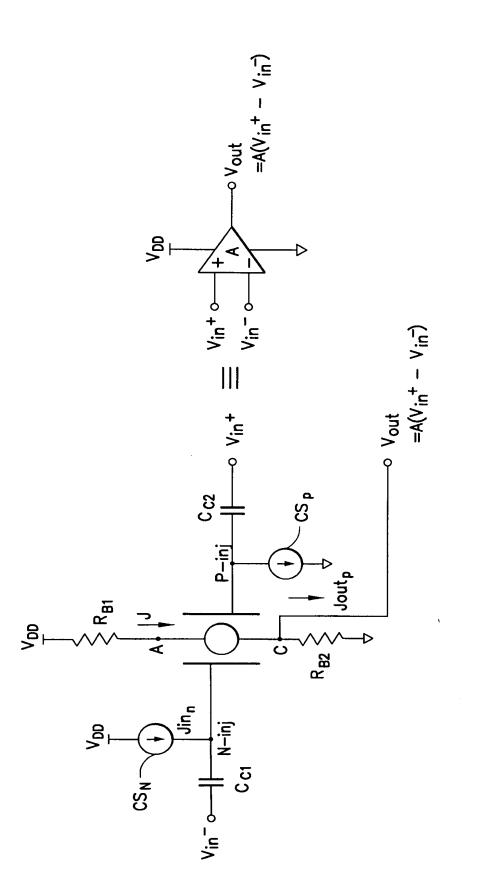
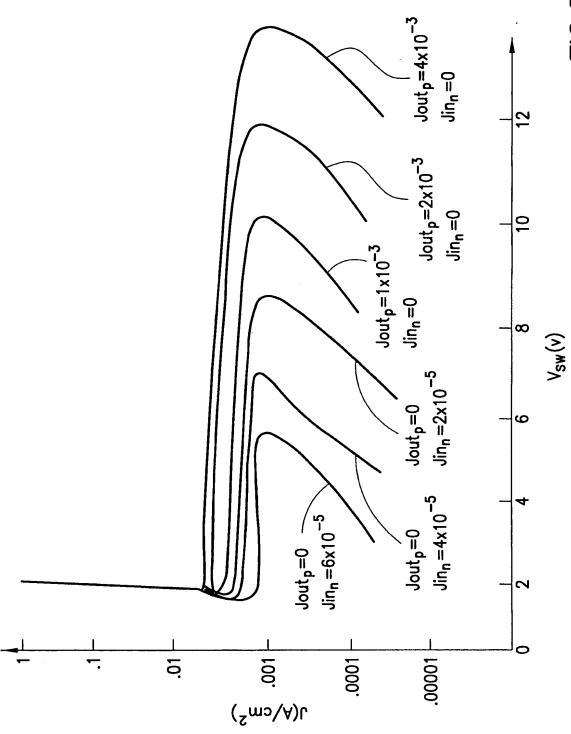


FIG.3C1



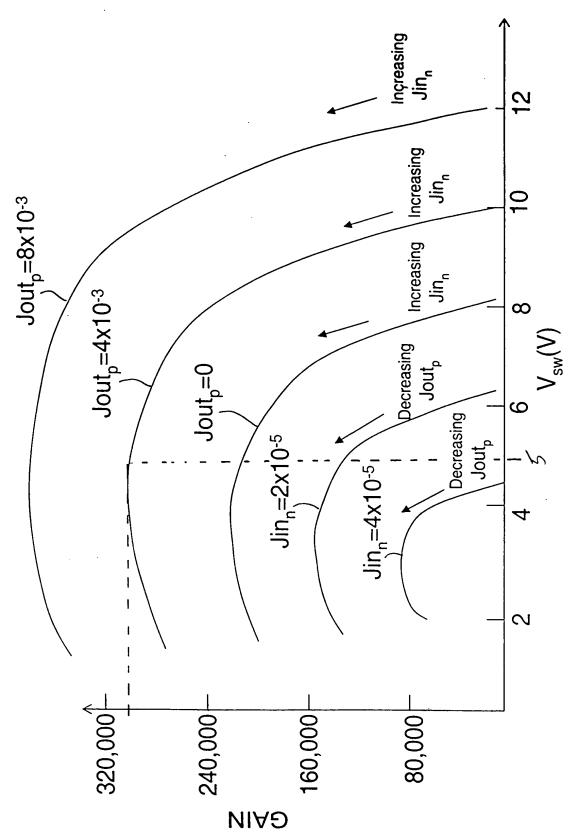
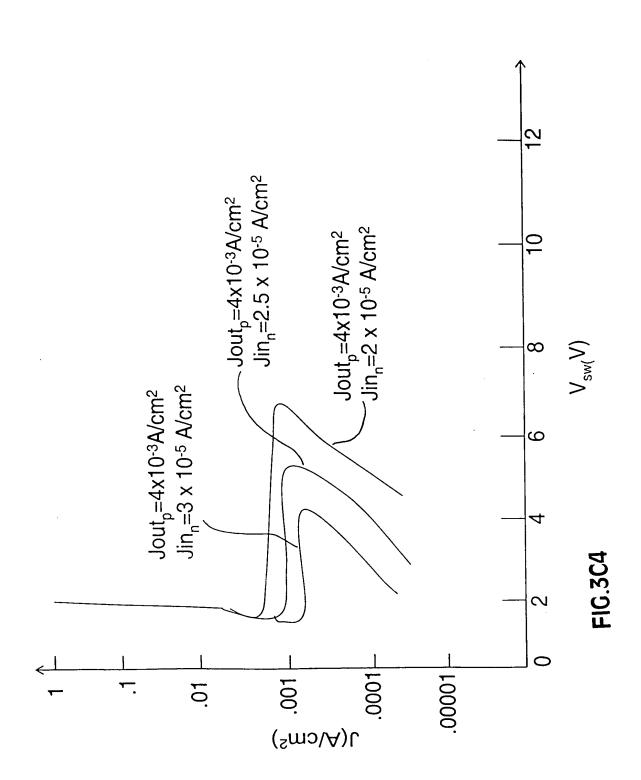
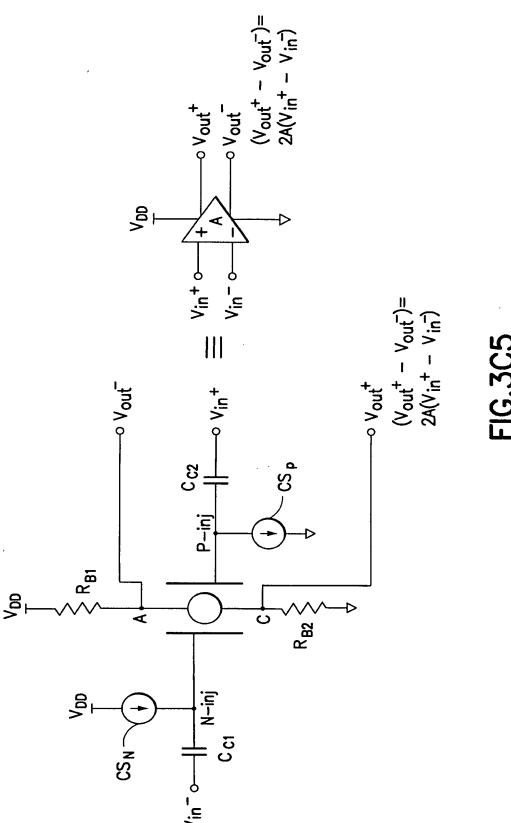
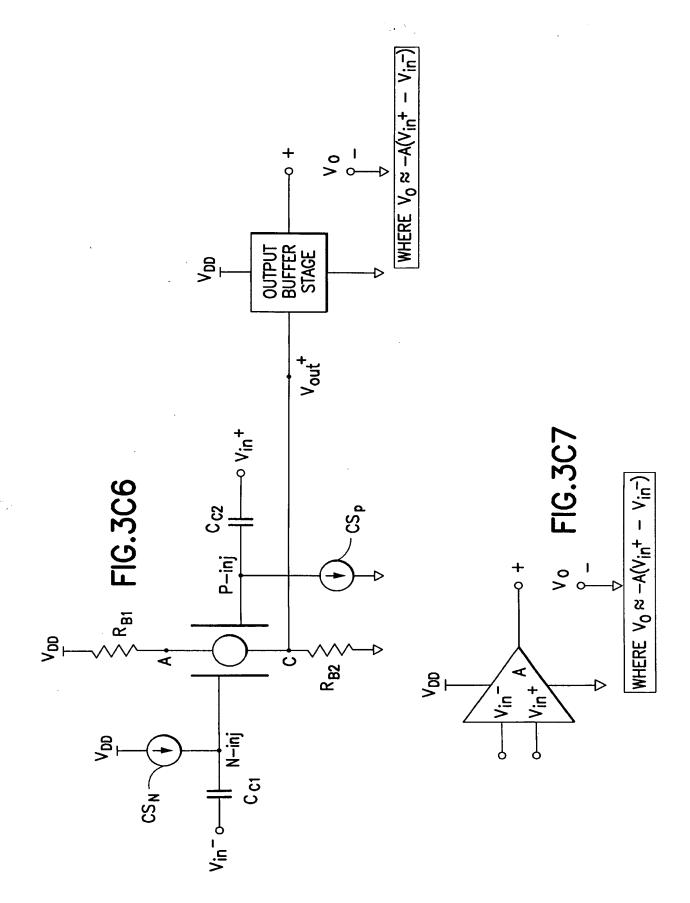
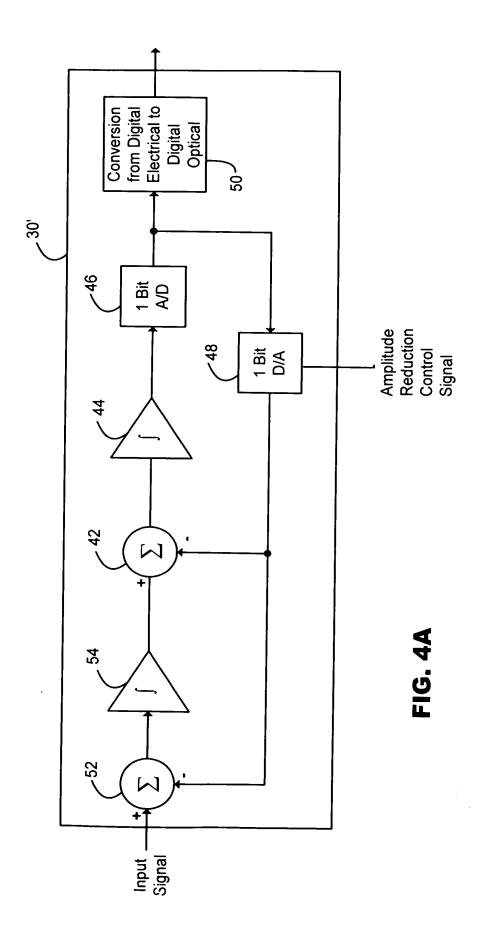


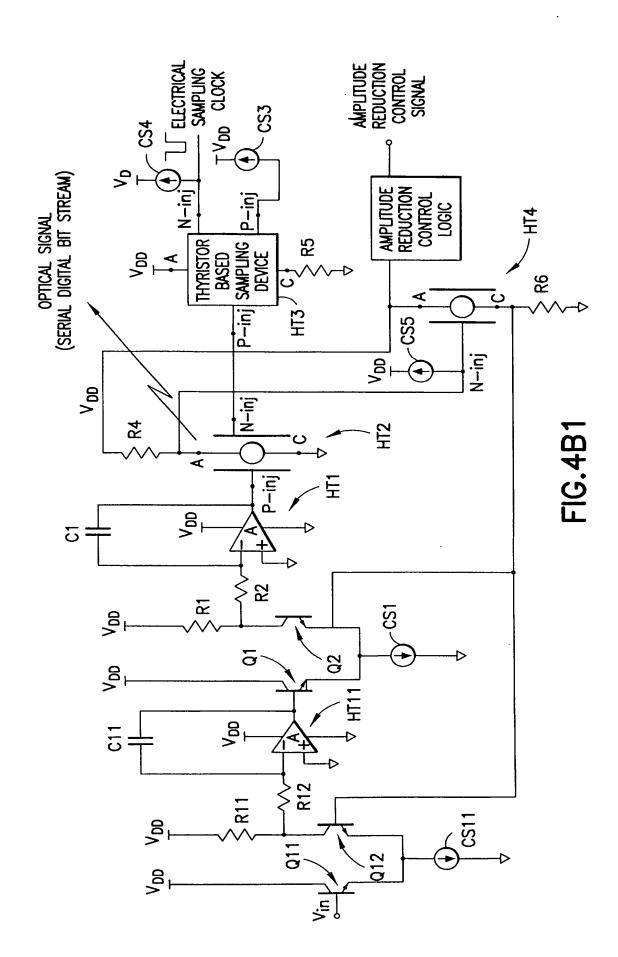
FIG.3C3

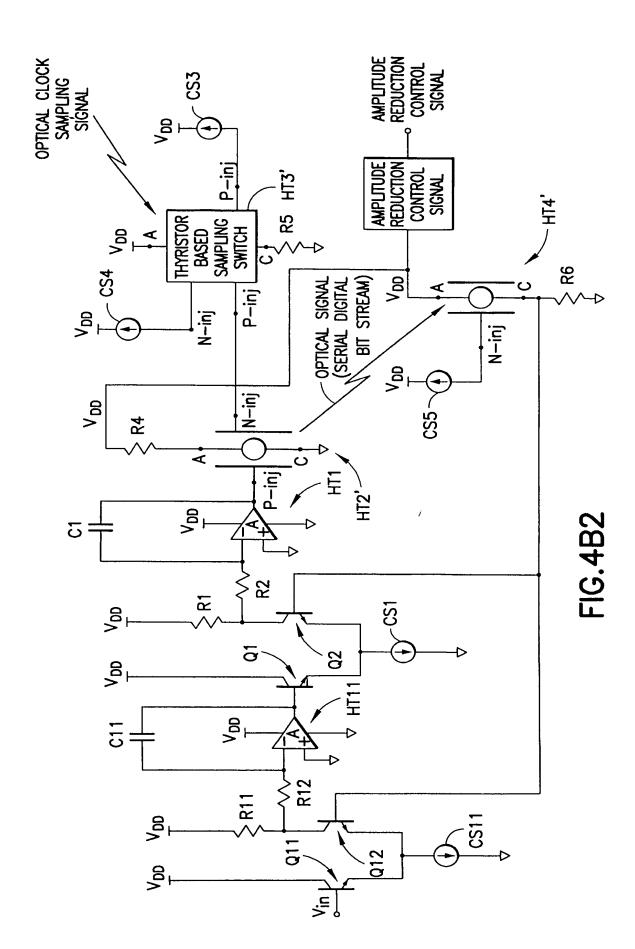












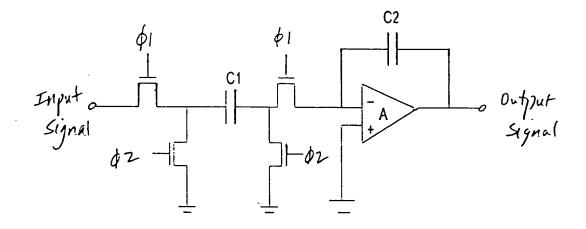
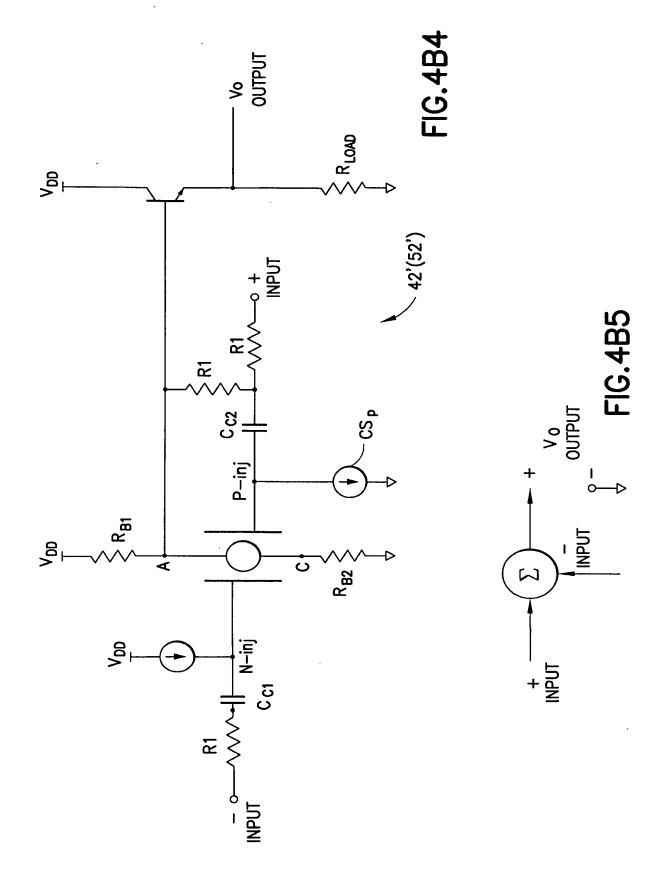
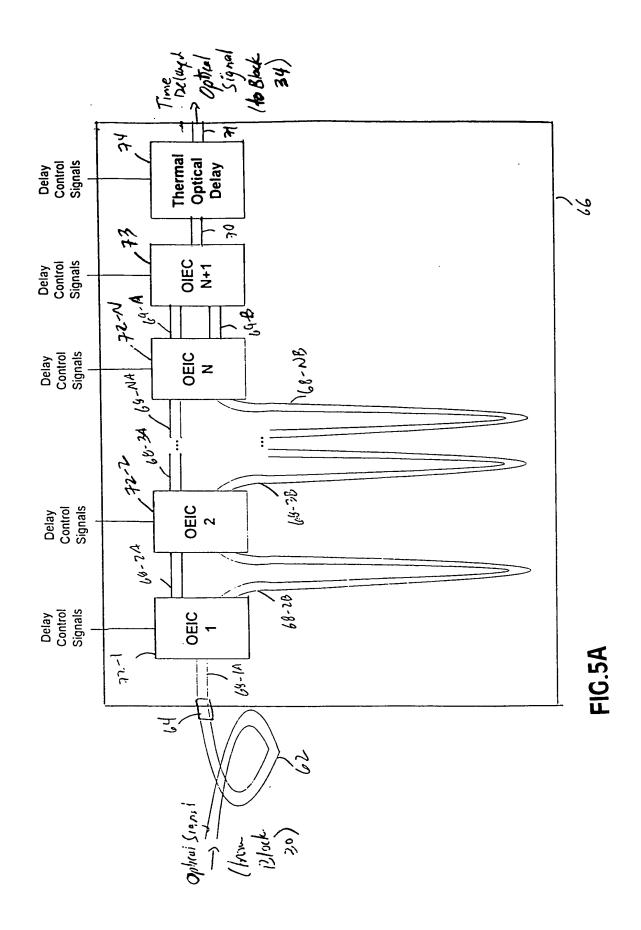


FIG.4B3





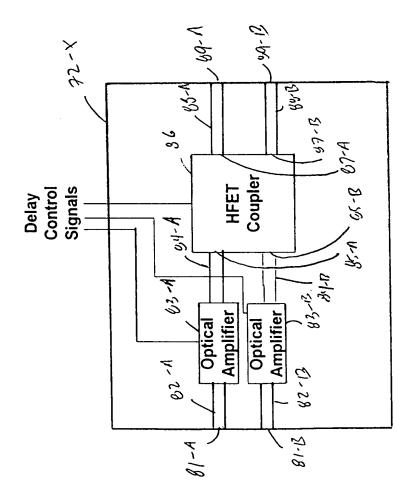
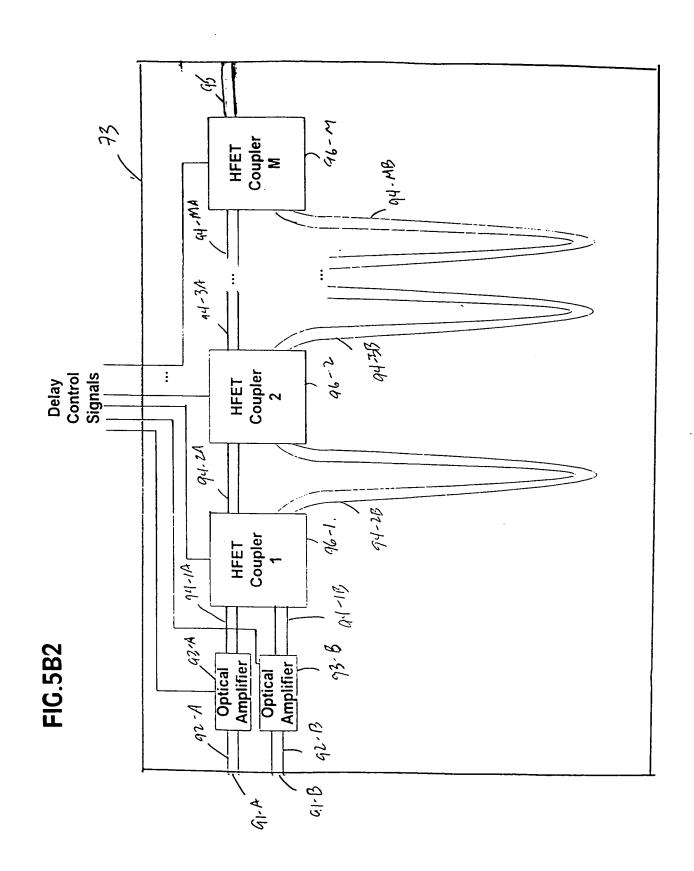
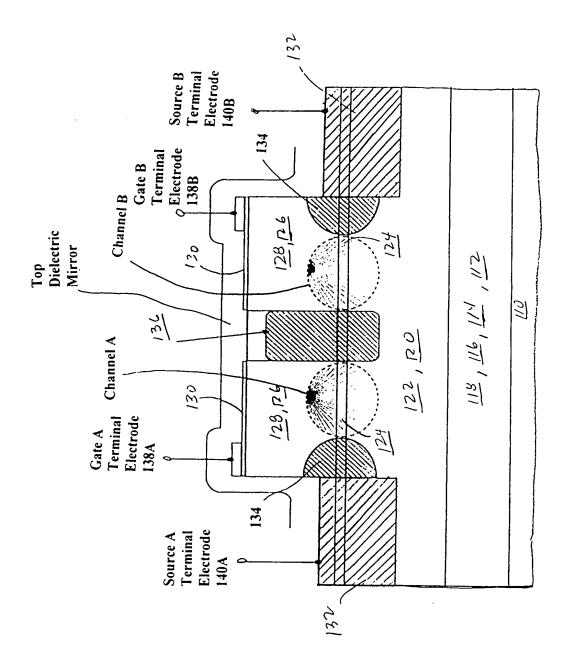


FIG.5B1





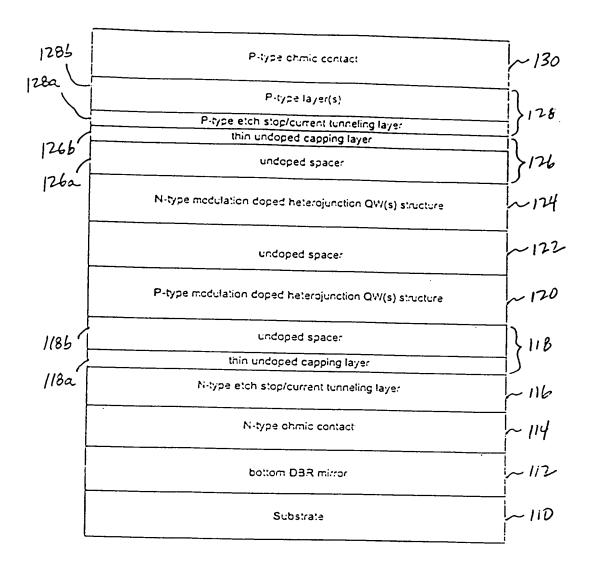
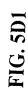
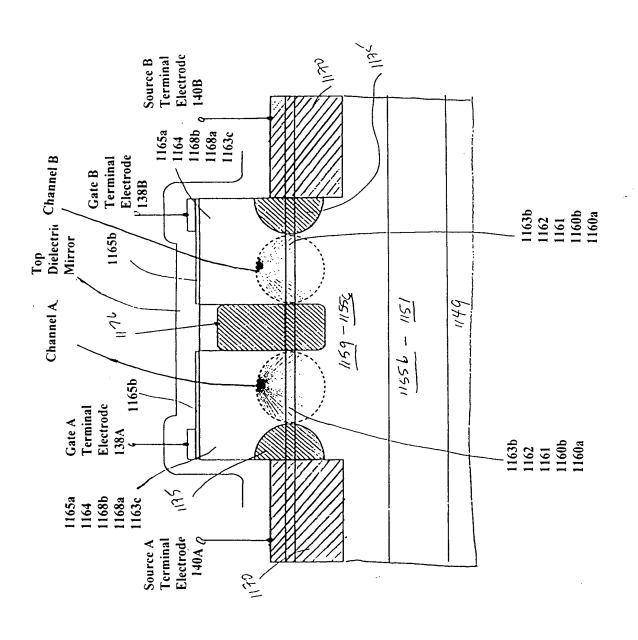


FIG.5C2





Layer Malerial	Layer Doping Type	Typical Doping Concentration (atoms/cm ⁻³)	Typical Layer Thickness (A)	Layer#
InGass	0.	1E20	-	
Cals	0.	1E20	25	11656
Gals	1 6	T	75	1165a
AlAs	10.	1-5E17	300	[164
Gals	lund	3 5E18	>20 . <300	11685
A: 15Ga 85As		und	>6. <20	1168a
A: 15Ga 85As A: 15Ga 85As	n.	und	200 - 300	1163c
Al.15Ga.85As		3.5E18	80	11635
GaAs	und	und	20-30	1163a
In.15Ga.85AsN)	und	und	15	1162
GaAs X3	und	und	60	1161
GaAs	und	und	100	1160b
Al.15Ga.85As	นกฮ	und	100 - 250	1160a
GaAs	und	und	5000	1159
GaAs)	und	und	250 - 500	1167
In.15Ga.85AsN X3	und	und	100	1158
GaAs	und	und	60	1157
Al.15Ga.85As	עהל	und	15	1156
Al.15Ga.85As	und	und	30	1155d
Al.15Ga.85As	P+	3.5E18	80	1155c
GaAs	und	und	200-300	1155b
A!As	und	und	>6 ,<20	/166b
GaAs	Ni+	3.5E18	>30,<200	1166a
AlAs	No	3.5E18	1000 - 2000	1153
GaAs } X7		und	1701	/151
A'As			696	1152
GaAs Substrate		und SI	1701	1151

FIG.5D2

